

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		09/772,994	MORIZANE ET AL.	
Examiner		Art Unit		Page 1 of 1
Brian L. Mutschler		1753		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,407,329	06-2002	Iino et al.	136/251
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Komada et al., "Novel Transparent Gas Barrier Film Prepared by PECVD Method", 43rd Annual Technical Conference Proceedings of the Society of Vacuum Coaters (April 15-20, 2000) pp. 353-356.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.